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Substitute for form 1449/PTO		Complete if Known			
	INFORMATION	DISCLOSURE	Application Number	10/584,340	
	STATEMENT BY		Filing Date	9/24/2004	
			First Named Inventor	Tadahiro OHMI	
	Date Submitted: Fe	ebruary 12, 2010	Art Unit	1792	
	(use as many shee	ts as necessary)	Examiner Name	Keath T. Chen	
Sheet	1	of 1	Attorney Docket Number	039262-0153	

U.S. PATENT DOCUMENTS						
Examin	Cite	Document Number  Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
er Initials*	No.1					

UNPUBLISHED U.S. PATENT APPLICATION DOCUMENTS						
Examiner Initials*	Cite No.1	U.S. Patent Application Document Serial Number-Kind Code <sup>2</sup> (if known)	Filing Date of Cited Document MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	

Examiner Initials*	Cite No.1	Foreign Patent Document Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
/K.C./	A1	JP 11-297672 (A)	10-29-1999	ULTLA CLEAN TECHNOLOGY KAIHATS		ABS
/K.C./	A3 JP 2003-163204 (A)	03-07-2003 06-06-2003	HITACHI LTD. HITACHI LTD.; HITACHI HIGH-TECHNOLOGIES CORP.		AB:	

		NON PATENT LITERATURE DOCUMENTS	_
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